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	Filing Date		2006-05-01	
	First Named Inventor	Ryoji FUNAHASHI		
	Art Unit			
	Examiner Name	Not yet assigned		
Attorney Docket Number		062440		

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	1	R. Chiba et al. "Properties of La1-ySryNi-xFexO3 as a cathode material for a low-temperature operating SOFC", Solid State Ionics, Vol. 152-153, pages 575 to 582 (2002)	<input type="checkbox"/>
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	3	P. Odier et al., "Sol-gel synthesis and structural characterization of the perovskite type pseudo solid solution LaNi0.5Cu0.5O3", Journal of Materials Chemistry, Vol. 12, pages 1370 to 1373 (2000)	<input type="checkbox"/>

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4	R. Funahashi et al., "Thermoelectric properties of Ln-Ni-O (Ln : lanthanoid) system", 22nd International Conference on Thermoelectric, pages 184 to 187 (2003)	<input type="checkbox"/>
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6	R. Furuhashi et al., "High-throughput screening of thermoelectric oxides and power generation modules consisting of oxide uncouples", Measurement Science and Technology, Vol.15, pages 1 to 11 (2004)	<input type="checkbox"/>
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- ☐ See attached certification statement.
- ☐ Fee set forth in 37 CFR 1.17 (p) has been submitted herewith.
- ☐ None

SIGNATURE

A signature of the applicant or representative is required in accordance with CFR 1.33, 10.18. Please see CFR 1.4(d) for the form of the signature.

Signature	/William F. Westerman/	Date (YYYY-MM-DD)	2006-08-01
Name/Print	William F. Westerman	Registration Number	29988

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